

Professor Benny C.F. Cheung is the Chair Professor of Ultra-precision Machining and Metrology at the Department of Industrial and Systems Engineering (ISE) of The Hong Kong Polytechnic University. Currently. he is also the Director of State Key Laboratory of Ultraprecision Machining Technology and the Director of The Hong Kong Polytechnic University-Wenzhou Technology and Innovation Research Institute. He holds various honorary positions in other universities and professional bodies including Adjunct Professorship of Changchun University of Science and Technology, Board Member of the Asian Society for Precision Engineering and Nanotechnology (ASPEN), a Fellow of the International Academy for Production Engineering (CIRP). His main research interests include ultra-precision machining precision surface metrology and smart precision manufacturing. He has received many research prizes and awards including the 2008 ASAIHL-Scopus Young Scientist Awards – First Runner Up Prize in the category of "Engineering and Technology", Joseph Whitworth Prize 2010 and A M Strickland Prize 2017 by The Institution of Mechanical Engineers (IMechE), UK, 2017 Winner of the IET Innovation Award - Manufacturing Technology, The Institution of Engineering and Technology (IET), UK, Bank of China Hong Kong (BOCHK) Science and Technology Innovation Prize 2023 – Advanced Manufacturing, etc.